



SF6新气痕量杂质气相色谱分析新方法

裘吟君, 陈晓琳, 姜宏仁

摘要: 介绍了一种SF6新气痕量杂质气相色谱分析的新方法。与DL/T 920—2005《六氟化硫中空气、四氟化碳的气相色谱分析方法》相比较, 新方法可以从SF6新气中检出更多的痕量杂质, 甚至多达17种, 且方法高度智能化并便于普及。考虑到SF6新气中某些杂质会影响有关电力设备的使用寿命, 提出了电力行业SF6新气推荐标准的方案。

关键词: SF6新气; 痕量杂质; 色谱方法; 标准

A New Trace Impurity Gas Chromatography Analysis Method for SF6 New Gas and Recommended Standard of SF6 New Gas for Electric Power Industry

QIU Yinjun, CHEN Xiaolin, JIANG Hongren

Abstract: A new chromatography analysis method of trace impurity in SF6 new gas is introduced. In comparesion with the method given in the DLT/920-2005, this new method can detect more kinds of trace impurity from SF6 new gas, even up to 17, and it is intellectualized highly and easy to be popularized. Considering the fact that some kinds of trace impurity in SF6 new gas endangers the lifespan of the power devices involved in SF6, the paper puts forward a scheme of recommendation standards of SF6 new gas for the electric power industry.

Key words: SF6 new gas; trace impurity; chromatograph method; standard

点击此处下载

关闭窗口